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				Application Number	Herewith
				Filing Date	
				First Named Inventor	Chen et al
				Group Art Unit	
				Examiner Name	
Sheet	1	of	6	Attorney Docket Number	100202586-5

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cita No.†	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code* (# known)			
		20020079432	A1	Lee et al.	06-27-2002	
		20020075554	A1	Brophy et al.	06-20-2002	
		20020070723	A1	Herbert et al.	06-13-2002	
		20020061160	A1	Solgaard et al.	05-23-2002	
		20020054422	A1	Carr et al.	05-09-2002	
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		20020033048	A1	McIntosh et al.	03-21-2002	
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				First Named Inventor	Chen et al
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Sheet	2	of	6	Attorney Docket Number	100202586-5

U.S. PATENT DOCUMENTS					Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
Examiner Initials*	Cite No.†	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document† MM-DD-YYYY
		Number	Kind Code² (if known)		
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Sheet	3	of	6	Attorney Docket Number	100202586-5

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.†	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T?
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	Herewith
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ²	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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		D. M. BURNS et al., Development of microelectromechanical variable blaze gratings, Sensors and Actuators A:Physical, Vol 64 No 1 1998 pp 7-15	
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Notice of References Cited	Application/Control No. 10/280,995		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Jack Dinh		Art Unit 2873	6 of 6

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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X	B	US-2002/0196546	12-2002	Fabiny, Larry	359/571
	C	US-			
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